# REQUEST FOR TRANSMITTAL MAIL STOP RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 Subsection (b) of 35 U.S.C. §132, effective on May 29, 2000, provides for continued examination of an utility or plant application filed on or after June 8, 1995. This is a Request for Continued Examination (RCE) under 3 1. SUBMISSION REQUIRED UNDER 37 C.F.R. §1.114 a. Previously submitted i. Please enter and consider the amendment(s)/repreviously filed on ii Consider the arguments in the Appeal Brief or

09/817,233 Application Number Confirmation Number 8072 Filing Date March 27, 2001 Ryo KUBOTO First Named Inventor 2823 Group Art Unit Hsien Ming LEE Examiner Name Q62494 Matter Number MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE HAVING

Title **DRAM CAPACITORS** This is a Request for Continued Examination (RCE) under 37 C.F.R. §1.114 of the above-identified application. 1. SUBMISSION REQUIRED UNDER 37 C.F.R. §1.114 i. Delease enter and consider the amendment(s)/reply under 37 C.F.R. §1.116 Consider the arguments in the Appeal Brief or Reply Brief previously filed on ii. 🗆 iii. 🗆 b. \( \overline{\Omega} \) Enclosed i. 🗹 Amendment/Reply ii. □ Affidavit(s)/Declaration(s) Information Disclosure Statement (IDS) iii. 🗆 Petition for Extension of Time with appropriate fee iv. 🗹 v. 🗆 Other 2. MISCELLANEOUS Suspension of action on the above-identified application is requested under 37 C.F.R. §1.103(c) for a period of \_\_\_\_\_ months b. □ 3. FEES A check for the RCE statutory fee of \$790.00 is attached. The USPTO is directed and authorized to charge all additional required fees (except the Issue/Publication Fees) to our Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this transmittal letter is also attached. **CORRESPONDENCE ADDRESS** Direct all correspondence to the address for SUGHRUE MION, PLLC filed under the Customer Number listed below: 08/04/2005 JADDO1 00000058 09817233 WASHINGTON OFFICE 23373 790.00 OP 01 Fd:1801 CUSTOMER NUMBER SIGNATURE OF ATTORNEY Registration No. 52,049 Name Amelia F. Morani, Ph.D. Signature amelia FMO PM Date August 3, 2005



## PATENT APPLICATION Q62494

Group Art Unit: 2823

Examiner: Hsien Ming LEE

# IN THE UNITED STATES PATENT & TRADEMARK OFFICE

In re application of

Ryo KUBOTO, et al.

Appln. No.: 09/817,233

Confirmation No.: 8072

Filed: March 27, 2001

MANUFACTURING METHOD OF SEMICONDUCTOR

**DEVICE HAVING DRAM CAPACITORS** 

# AMENDMENT UNDER 37 C.F.R. §1.114(c)

## **MAIL STOP RCE**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

For:

In response to the Final Office Action dated February 3, 2005, please amend the abovecaptioned application as follows on the accompanying pages.

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